

## Lecture 12 - Carrier Flow (*cont.*)

March 2, 2007

### Contents:

1. Transport in space-charge and high-resistivity regions
2. Carrier multiplication and avalanche breakdown

### Reading assignment:

del Alamo, Ch. 5, §5.7

### Seminar:

Matthias Passlack (Freescale Semiconductor) *High Mobility III-V MOSFET Technology*. March 6, 2007, 4:5 PM (reception at 3:30 PM).

## Key questions

- What characterizes space-charge-region-type situations?
- How does impact ionization affect space-charge-region type situations?

## 1. Transport in space-charge and high-resistivity regions

In regions with very low carrier concentrations:

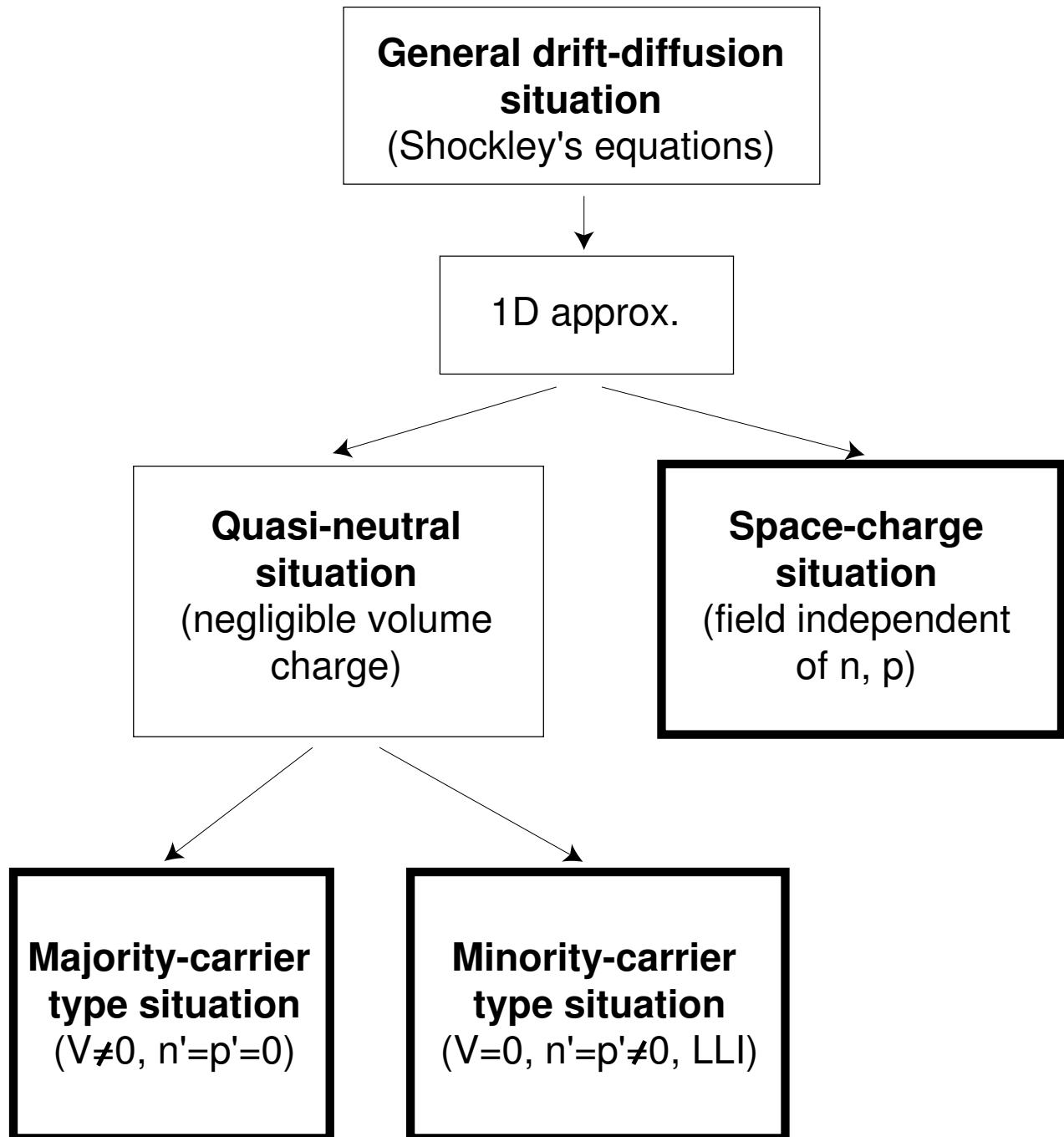
- *dielectric relaxation time long* → majority carriers take a long time to screen out charge perturbations  
*i.e.*: for  $10^{12} \text{ cm}^{-3}$  Si ( $\rho \simeq 10^4 \Omega \cdot \text{cm}$ ),  $\tau_d \simeq 10 \text{ ns}$
- *Debye length long* → net charge can exist over substantial spatial extent  
*i.e.*: for  $10^{12} \text{ cm}^{-3}$  Si,  $L_D \simeq 4 \mu\text{m}$

Transport physics quite different from QN regions.

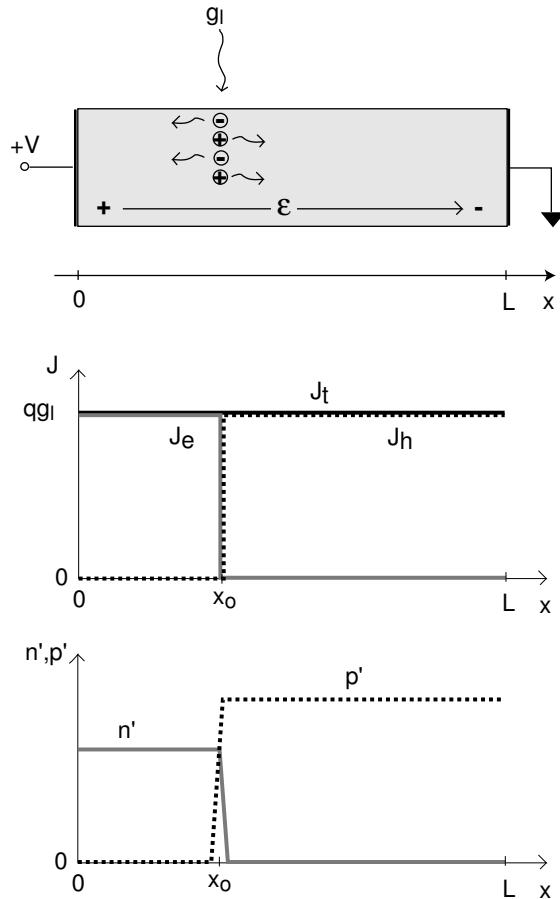
Key approximation:  $\mathcal{E}$  independent of  $n$ ,  $p$ :

- $\mathcal{E}$  imposed from outside (*i.e.* high resistivity region under bias), or
- $\mathcal{E}$  set by spatial distribution of dopants (*depletion region*)

## Overview of simplified carrier flow formulations



## Example: Drift in a high-resistivity region under external electric field



Electric field separates photogenerated carriers:

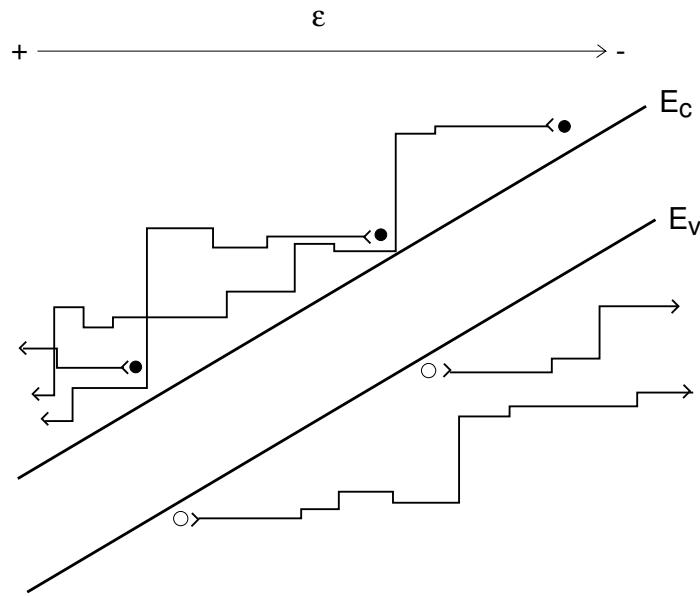
$$J_e = qg_l \quad \text{for } x < x_o$$

$$J_h = qg_l \quad \text{for } x > x_o$$

$$J_t = qg_l \quad \text{everywhere}$$

### 3. Carrier multiplication and avalanche breakdown

If  $\mathcal{E}$  high, impact ionization may take place  $\rightarrow$  *carrier multiplication*



If  $\mathcal{E}$  high enough, *carrier avalanche* possible  $\rightarrow$  **avalanche breakdown**

- Dominant breakdown mechanism in semiconductor devices  $\rightarrow$  imposes limit to maximum voltage
- Noisy

Impact ionization → new generation mechanism:

$$G_{ii} = \alpha_e |F_e(\text{drift})| + \alpha_h |F_h(\text{drift})|$$

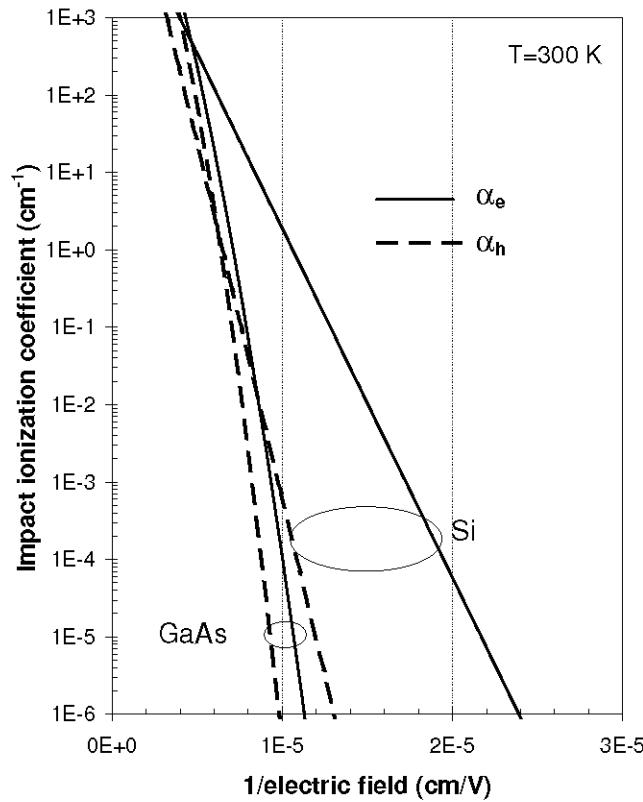
$\alpha_e \equiv$  electron impact ionization rate ( $\text{cm}^{-1}$ )

$\alpha_h \equiv$  hole impact ionization rate ( $\text{cm}^{-1}$ )

$\alpha \equiv$  average number of ionizations per unit length per carrier

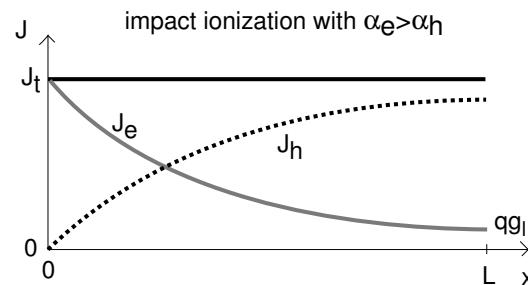
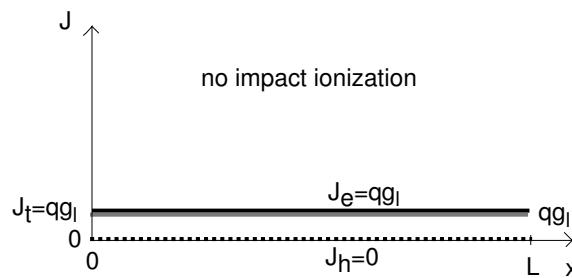
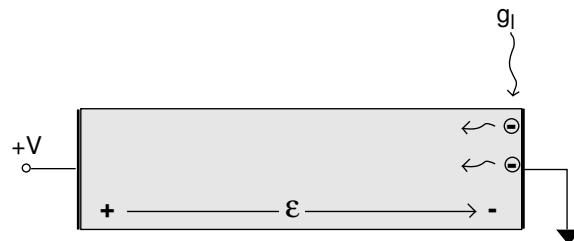
$1/\alpha \equiv$  mean distance between II events per flowing carrier

$\alpha$  is strongly dependent on  $\mathcal{E}$ :



## Example: carrier multiplication in a high-resistivity region with uniform electric field

High-resistivity uniformly-doped sample under  $\mathcal{E}$ :



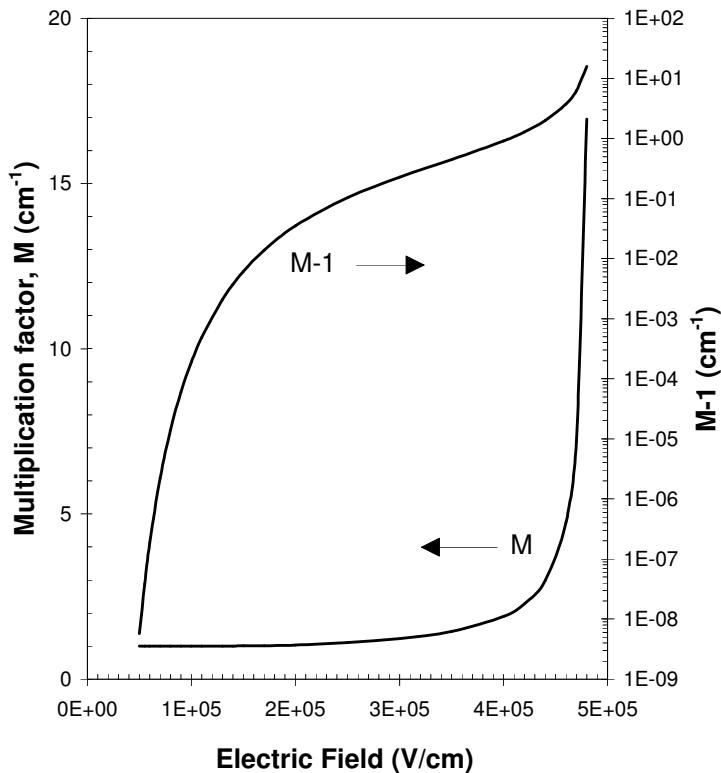
$$J_t = qg_l M \geq qg_l$$

$M \equiv$  Multiplication coefficient [n.u.]

Two limits to  $M$ :

- if  $\mathcal{E}$  small,  $M \rightarrow 1$
- for high enough  $\mathcal{E}$ ,  $M$  diverges: avalanche breakdown

Calculation for 1  $\mu m$  long Si sample:



For example above:

- *critical breakdown field*:  $E_b = 4.9 \times 10^5 \text{ V/cm}$
- *Breakdown voltage*:  $BV = 49 \text{ V}$

## Key conclusions

- In a quasi-neutral, charge redistribution takes place in scale of *dielectric relaxation time*.
- Majority-carrier type situations can be considered quasi-static.
- Minority-carrier type situations show substantial memory.
- Time constants in minority-carrier type situations:
  - carrier lifetime
  - transit time  $\propto L^2/D$
  - whichever one is smallest dominates
- SCR/high-resistivity regions:
  - electric field independent of carrier concentrations
  - behavior of electrons and holes independent of each other and of the background carrier concentrations
- Carrier multiplication can lead to avalanche breakdown at high fields → limit to maximum voltage: **breakdown voltage**.
- Order of magnitude of key parameters in Si at 300K:
  - Dielectric relaxation time:  $\tau_d < 1 \text{ ps}$  (for typical doping levels).

## Self study

- Simplification of Shockley's equations for space-charge and high-resistivity regions
- Comparison between SCR and QNR transport.